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02/11/02

U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10074534	02/11/2002	438		2812	

****APPLICANTS:** Todd Michael

****CONTINUING DATA VERIFIED:**
 THIS APPLN CLAIMS BENEFIT OF 60 268 337 02/12/2001
 AND CLAIMS BENEFIT OF 60 279 256 03/27/2001
 AND CLAIMS BENEFIT OF 60 311 609 08/09/2001
 AND CLAIMS BENEFIT OF 60 323 645 09/19/2001
 AND CLAIMS BENEFIT OF 60 332 696 11/13/2001
 AND CLAIMS BENEFIT OF 60 333 724 11/28/2001
 AND CLAIMS BENEFIT OF 60 340 454 12/07/2001

****FOREIGN APPLICATIONS VERIFIED:**

PC PUB ☐ DO NOT PUBLISH ☐ RESCIND ☐

Foreign priority claimed ☐ yes ☐ no
 35 USC 119 conditions met ☐ yes ☐ no
 Verified and Acknowledge Examiner's initials

ATTORNEY DOCKET NO
ASMEX 067A

TITLE : Process for deposition of semiconductor films

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner	
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